



STW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77312

Hiroshi TANABE, et al.

Appln. No.: 10/674,396

Group Art Unit: 2812

Confirmation No.: 4416

Examiner: Karla A. Moore

Filed: October 01, 2003

For: SEMICONDUCTOR MANUFACTURING APPARATUS AND MANUFACTURING  
METHOD OF THIN FILM SEMICONDUCTOR DEVICE

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 9, 2005, please amend the above-identified application as follows on the accompanying pages.

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